

STN	Meranie parametrov kremenných kryštálových jednotiek Časť 8: Skúška upevnenia kremenných kryštálových jednotiek pre povrchovú montáž	STN EN 60444-8 35 8490
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Measurement of quartz crystal unit parameters - Part 8 : Test fixture for surface mounted quartz crystal units

Táto norma obsahuje anglickú verziu európskej normy.
This standard includes the English version of the European Standard.

Táto norma bola oznámená vo Vestníku ÚNMS SR č. 07/17

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EUROPEAN STANDARD
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EN 60444-8

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English Version

Measurement of quartz crystal unit parameters -
Part 8 : Test fixture for surface mounted quartz crystal units
(IEC 60444-8:2016)

Mesure des paramètres des résonateurs à quartz -
Partie 8: Dispositif d'essai pour les résonateurs
à quartz montés en surface
(IEC 60444-8:2016)

Messung von Schwingquarz-Parametern -
Teil 8: Prüfaufbau für oberflächenmontierbare
Schwingquarze
(IEC 60444-8:2016)

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Europäisches Komitee für Elektrotechnische Normung

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European foreword

The text of document 49/1126/CDV, future edition 2 of IEC 60444-8, prepared by IEC/TC 49 "Piezoelectric, dielectric and electrostatic devices and associated materials for frequency control, selection and detection" was submitted to the IEC-CENELEC parallel vote and approved by CENELEC as EN 60444-8:2017.

The following dates are fixed:

- latest date by which the document has to be implemented at (dop) 2017-10-19
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- latest date by which the national standards conflicting with (dow) 2020-01-19
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In the official version, for Bibliography, the following notes have to be added for the standards indicated:

IEC 60122-1	NOTE	Harmonized as EN 60122-1.
IEC 60444-1:1986	NOTE	Harmonized as EN 60444-1:1997 (not modified).
IEC 60444-2	NOTE	Harmonized as EN 60444-2.
IEC 60444-6	NOTE	Harmonized as EN 60444-6.
IEC 60444-7	NOTE	Harmonized as EN 60444-7.
IEC 60444-9	NOTE	Harmonized as EN 60444-9.
IEC 61837-1	NOTE	Harmonized as EN 61837-1.
IEC 61837-2	NOTE	Harmonized as EN 61837-2.
IEC 61837-3	NOTE	Harmonized as EN 61837-3.
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Annex ZA

(normative)

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NOTE 2 Up-to-date information on the latest versions of the European Standards listed in this annex is available here: www.cenelec.eu.

<u>Publication</u>	<u>Year</u>	<u>Title</u>	<u>EN/HD</u>	<u>Year</u>
IEC 60444-5	-	Measurement of quartz crystal unit parameters - Part 5: Methods for the determination of equivalent electrical parameters using automatic network analyzer techniques and error correction	EN 60444-5	-



IEC 60444-8

Edition 2.0 2016-12

INTERNATIONAL STANDARD



Measurement of quartz crystal unit parameters – Part 8: Test fixture for surface mounted quartz crystal units



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IEC 60444-8

Edition 2.0 2016-12

INTERNATIONAL STANDARD



Measurement of quartz crystal unit parameters – Part 8: Test fixture for surface mounted quartz crystal units

INTERNATIONAL
ELECTROTECHNICAL
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INTERNATIONAL ELECTROTECHNICAL COMMISSION

MEASUREMENT OF QUARTZ CRYSTAL UNIT PARAMETERS –**Part 8: Test fixture for surface mounted quartz crystal units****FOREWORD**

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International Standard IEC 60444-8 has been prepared by IEC technical committee 49: Piezoelectric, dielectric and electrostatic devices and associated materials for frequency control, selection and detection.

This second edition cancels and replaces the first edition published in 2003. This edition constitutes a technical revision.

This edition includes the following significant technical changes with respect to the previous edition:

- a) modification of Clause 1;
- b) modification of 5.2;
- c) modification of 5.3;
- d) modification of 5.4;

e) 6.3 Calibration of the reflection measurement system.

The text of this standard is based on the following documents:

CDV	Report on voting
49/1126/CDV	49/1175/RVC

Full information on the voting for the approval of this standard can be found in the report on voting indicated in the above table.

This publication has been drafted in accordance with the ISO/IEC Directives, Part 2.

A list of all parts in the IEC 60444 series, published under the general title *Measurement of quartz crystal unit parameters*, can be found on the IEC website.

The committee has decided that the contents of this publication will remain unchanged until the stability date indicated on the IEC web site under "<http://webstore.iec.ch>" in the data related to the specific publication. At this date, the publication will be

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INTRODUCTION

This document focuses on test fixtures applied to leadless surface mounted quartz crystal units. The document is the specification for fixtures [1][2]¹ that allow the measurement of (series) resonance frequency, (series) resonance resistance, and equivalent electrical circuit parameters of leadless surface mounted quartz crystal units. The measurement method using an automatic network analyzer with error correction is described in IEC 60444-5, which also contains proposals for test fixtures for quartz crystal units in through-hole packages.

The measuring frequency range is from 1 MHz to 1 200 MHz, and is limited to 1 MHz to 30 MHz, if a physical load capacitance is used. The use of the test fixtures in connection with error correction measurement techniques yields measurement accuracy of about 10^{-6} over of the frequency range, and the accuracy of the resonance resistance is $\pm 2 \Omega$ or $\pm 10 \%$.

This document forms Part 8 of a series of publications dealing with measurements of quartz crystal unit parameters.

The IEC 60444 series consists of the following parts under the general title *Measurement of quartz crystal unit parameters*:

- Part 1: Basic method for the measurement of resonance frequency and resonance resistance of quartz crystal units by zero phase technique in a π -network
- Part 2: Phase offset method for measurement of motional capacitance of quartz crystal units
- Part 4: Method for the measurement of the load resonance frequency f_L , load resonance resistance R_L and the calculation of other derived values of quartz crystal units, up to 30 MHz
- Part 5: Methods for the determination of equivalent electrical parameters using automatic network analyzer techniques and error correction
- Part 6: Measurement of drive level dependence (DLD)
- Part 7: Measurement of activity and frequency dips of quartz crystal units
- Part 8 Text fixture for surface mounted quartz crystal units
- Part 11 Standard method for the determination of the load resonance frequency f_L and the effective load capacitance C_{Leff} using automatic network analyzer techniques and error correction.

¹ Numbers in square brackets refer to the Bibliography.

MEASUREMENT OF QUARTZ CRYSTAL UNIT PARAMETERS –

Part 8: Test fixture for surface mounted quartz crystal units

1 Scope

This part of IEC 60444 describes test fixtures suitable for leadless surface mounted quartz crystal units in enclosures as defined in IEC 61837 (all parts). These fixtures allow the measurement of (series) resonance frequency, (series) resonance resistance, and equivalent electrical circuit parameters L_1 , C_1 and C_0 using the measurement techniques specified in IEC 60444-5 and for the determination of load resonance frequency and load resonance resistance according to IEC TR 60444-4 and IEC 60444-11.

Two test fixtures are described in this document:

- 1) A fixture using the π -network circuit with electrical values as described in IEC 60444-1 for measurements in transmission mode up to 500 MHz. This fixture includes optional means to add physical load capacitors for the measurement of load resonance parameters up to 30 MHz in accordance with IEC 60444-4. The range of load capacitance is 10 pF or more. Calibration of the measurement system and C_L adapter board is explained hereinafter.
- 2) A fixture based on the reflection method, suitable for a frequency range up to 1 200 MHz. No provisions for adding a physical load capacitance are anticipated. Load resonance parameters can be measured by using the method of IEC 60444-11.

2 Normative references

The following documents are referred to in the text in such a way that some or all of their content constitutes requirements of this document. For dated references, only the edition cited applies. For undated references, the latest edition of the referenced document (including any amendments) applies.

IEC 60444-5, *Measurement of quartz crystal units parameters – Part 5: Methods for the determination of equivalent electrical parameters using automatic network analyzer techniques and error correction*

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